



PATENT
81208-0246275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

NIELSEN, HENRIK K. ET AL.

Serial No: 09/195,533

Filed: November 18, 1998

For: DETECTION SYSTEM FOR
NANOMETER SCALE TOPOGRAPHIC
MEASUREMENTS OF REFLECTIVE
SURFACES

) Art Unit: 2877

) Examiner: R. ROSENBERGER

12/Pre-
Am H
C
G. Stanley
1-4-01

PRELIMINARY AMENDMENT

Box CPA
Assistant Commissioner for Patents
Washington, D.C. 20231

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JAN 03 2001
TECHNOLOGY CENTER 2000

Dear Sir:

Prior to examination of this Continued Prosecution Application, please enter the following amendment and consider the remarks. This Continued Prosecution Application is responsive to the Final Office Action dated August 25, 2000, the deadline for response to which is extended by one month to December 26, 2000 (the first business day after Christmas Day, December 25, 2000) by the accompanying Petition for Extension of Time and the accompanying fee.